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APPLICATION NO.	FILI	NG DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/649,472	649,472 08/27/2003		Juing-Yi Cheng	N1085-90110	5371	
54657	7590	09/13/2005		EXAMINER		
DUANE MO			CHEN, KIN-CHAN			
IP DEPARTN 30 SOUTH 1	•	•		ART UNIT PAPER NUMBER		
PHILADELP	PHILADELPHIA, PA 19103-4196			1765		

DATE MAILED: 09/13/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	1/					
	10/649,472	CHENG ET AL.	V					
Office Action Summary	Examiner	Art Unit						
	Kin-Chan Chen	1765						
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence addre	!SS					
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA  - Extensions of time may be available under the provisions of 37 CFR 1.1: after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period v  - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	N. nely filed the mailing date of this comm D (35 U.S.C. § 133).	·					
Status								
1) Responsive to communication(s) filed on 12 A	ugust 2005.							
2a) ☐ This action is <b>FINAL</b> . 2b) ☐ This action is non-final.								
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is								
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.						
Disposition of Claims								
4) Claim(s) 25-39 is/are pending in the application	1.							
4a) Of the above claim(s) is/are withdrawn from consideration.								
5) Claim(s) is/are allowed.								
6)⊠ Claim(s) <u>25-39</u> is/are rejected.	· · · · · · · · · · · · · · · · · · ·							
7) Claim(s) is/are objected to.								
8) Claim(s) are subject to restriction and/o	r election requirement.							
Application Papers								
9) The specification is objected to by the Examine	г.							
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
Priority under 35 U.S.C. § 119								
	priority under 25 ILC C C 440(c)	(4) (5)						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:	phonty under 35 U.S.C. § 119(a)	-(a) or (t).						
1. Certified copies of the priority documents have been received.								
2. Certified copies of the priority documents have been received in Application No								
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).								
* See the attached detailed Office action for a list	· · · ·	d						
See the attached detailed Office action for a list	or the certified copies not receive	u.						
Attachment(s)								
1) Notice of References Cited (PTO-892)	4) Interview Summary	(PTO-413)						
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)	Paper No(s)/Mail Da 5) Notice of Informal Pa		2)					
Paper No(s)/Mail Date	6) Other:	ppilosilon (i 10-10.	-,					
U.S. Patent and Trademark Office	tion Cummon.	D-4 - 6 D 1 - 1 - 2 - 2 - 2	- 20222					
PTOL-326 (Rev. 7-05) Office Ac	tion Summary	Part of Paper No./Mail Dat	e 090805					

#### **DETAILED ACTION**

### Specification

1. The amendment filed August 12, 2005 is objected to under 35 U.S.C. 132(a) because it introduces new matter into the disclosure. 35 U.S.C. 132(a) states that no amendment shall introduce new matter into the disclosure of the invention. The added material which is not supported by the original disclosure is as follows: The amended abstract contains new matters such as replace "the silicon semiconductor substrate" with "a semiconductor substrate". Correction is required. See MPEP § 608.01(b).

Applicant is required to cancel the new matter in the reply to this Office Action.

## Claim Rejections - 35 USC § 112

2. Claims 25-39 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention.

In claim 25, line 3, the deletion of "silicon" has changed the scope of the invention, therefore, claims contains new matter.

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In claim 33, line 3, "forming a buffer layer over a semiconductor substrate" is new matter.

Claims 25-39 are rejected under 35 U.S.C. 112, first paragraph, because the specification, while being enabling for silicon semiconductor substrate does not reasonably provide enablement for generic semiconductor substrate (such as gallium arsenide, silicon-on-insulator, other semiconductor substrates). Applicant does not have support in the specification for generic semiconductor substrate. The scope of the claim goes beyond the scope justified by the description of the invention provided in the specification and drawings.

Claims 33-39 are rejected under 35 U.S.C. 112, first paragraph, because the specification, while being enabling for polysilicon buffer layer and nitride for the mask layer does not reasonably provide enablement for generic buffer layer and mask layer. Applicant does not have support in the specification for generic buffer layer and mask layer other than polysilicon and nitride. The scope of the claim goes beyond the scope justified by the description of the invention provided in the specification and drawings.

The specification (disclosure) must teach those skilled in the art how to make and use the full scope of the claimed invention without "undue experimentation". *In re Wright*, 999 F.2d 1557, 1561, 27 USPQ2d 1510, 1513 (Fed. Cir. 1993).

In claim 30, "first slurry has a selectivity of oxide to the nitride of greater than 3" is new matter.

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In claim 31, "second slurry has a selectivity of oxide to polysilicon of greater than

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3" is new matter.

3. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 25-39 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

In claim 25, applicant recites "a first slurry having low selectivity of oxide to the nitride" and "a second slurry having high selectivity of oxide to the polysilicon" while in claims 30 and 31, applicant recites that each of first slurry and second slurry has a selectivity of greater than 3, it is not clear what differentiates "high" and "low".

In claim 33, applicant recites "low selectivity slurry having a selectivity for the oxide layer relative to the mask layer" and "high selectivity slurry having a selectivity for the oxide layer relative to the buffer layer". The term "high" or "low" is a relative term with no basis for comparison because only polysilicon is defined in the specification. Thus the metes and bounds of the claim are unclear.

#### Conclusion

4. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP

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§ 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kin-Chan Chen whose telephone number is (571) 272-1461. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you

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have questions on access to the Private PAIR system, contact the Electronic Business

Center (EBC) at 866-217-9197 (toll-free).

September 8, 2005

Kin-Chan Chen Primary Examiner Art Unit 1765

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